OXIDATIVE COUPLING OF METHANE TO HIGHER HYDROCARBONS OVER ZEOLITE IN AC ELECTRIC DISCHARGES

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ABSTRACT

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The objective of this study was to investigate the oxidative coupling of methane to produce higher hydrocarbons by using a combination of AC electric discharges and zeolite catalyst at ambient conditions. It was found that with an increase in voltage, methane, oxygen and ethane conversions as well as yields of C₂ hydrocarbons (ethylene and acetylene) increased. The conversions of methane, oxygen and ethane, including yields of C₂ hydrocarbons decreased with increasing either frequency or flow rate. An increase in ethane partial pressure resulted in decreasing the conversions of methane and ethane. Pt/NaOH treated Y led to more significant methane and ethane conversions, while the highest oxygen conversion was obtained with Pt/KL and Pt/NaX. The results showed that the maximum yield of C₂ hydrocarbons was approximately 23 % when the system was operated over Pt/KL at 8,000 V, of 500 Hz, 50 ml/min flow rate of and methane to oxygen to ethane ratio of 4:2:1. The presence of Pt/KL zeolite also enhanced the conversion of oxygen and the selectivity of ethylene while, for the noncatalytic system, hydrogen and carbon monoxide were main products.

บทคัดย่อ

พรพิโล วิริยะศิริพงศ์กูล : ปฏิกิริยาออกซิเคทีปคับปลิงของมีเทนเพื่อผลิตก๊าซ ไฮโครคาร์บอนโมเลกุลใหญ่บนตัวเร่งปฏิกิริยาซีโอไลท์ภายใต้สนามไฟฟ้ากระแสสลับ (Oxidative Coupling of Methane to Higher Hydrocarbons over Zeolite in AC Electric Discharges) อ. ที่ปรึกษา : ศ. ริชาร์ค จี แมลลินสัน (Prof. Richard G. Mallinson) และ รศ. สุเมธ ชวเคช เอกสารจำนวน 66 หน้า ISBN 974-13-0681-4

วัตถุประสงค์ของงานศึกษานี้เพื่อศึกษาปฏิกิริยาออกซิเคทีปคัปปถิงของมีเทนเพื่อผลิต ก๊าซไฮโครคาร์บอนโมเลกุลใหญ่บนตัวเร่งปฏิกิริยาซีโอไลท์และภายใต้สนามไฟฟ้าแรงสูงกระแส สลับที่อุณหภูมิห้องและความดันบรรยากาศ จากการศึกษาพบว่า เมื่อทำการเพิ่มความต่างศักย์ใฟ ฟ้า ประสิทธิภาพการเปลี่ยนแปลงของก๊าซมีเทน,ออกซิเจนและอีเทนเพิ่มสูงขึ้นและประสิทธิภาพ การผลิตก๊าซไฮโครคาร์บอน(เอทิลีนและอเซททิลีน)สูงขึ้นด้วย ประสิทธิภาพการเปลี่ยนก๊าซมีเทน, ออกซิเจนและอีเทนรวมทั้งประสิทธิภาพการผลิตก๊าซไฮโครคาร์บอนลดลง เมื่อเพิ่มความถี่หรือ อัตราการใหลของก๊าซขาเข้า หรือเพิ่มอัตราส่วนของก๊าซอีเทนในก๊าซขาเข้า มีผลทำให้การเปลี่ยน แปลงของก๊าซมีเทนและอีเทนลคลง ตัวเร่งปฏิกิริยาแพลตินัมบนพื้นผิวโซเคียมไฮครอกไซต์ทรีทซี โอไลต์วายให้การเปลี่ยนแปลงของก๊าซมีเทนและอีเทนที่เค่นชัคกว่า ในขณะที่การเปลี่ยนแปลง ของก๊าซออกซิเจนสูงสุดเกิดบนตัวเร่งปฏิกิริยาแพลตินัมบนพื้นผิวโพแทสเซียมซีโอไลด์แอลและ โซเคียมซีโอไลต์เอ็กซ์ ผลการทคลองยังแสคงว่าประสิทธิภาพการผลิตสูงสุดของสาร ไฮโครคาร์บอนที่มีคาร์บอน 2 ตัวประมาณ 23 เปอร์เซ็นต์ เมื่อระบบถูกควบคุมบนตัวเร่งปฏิกิริยา แพลตินัมบนพื้นผิวโพแทสเซียมซีโอไลต์แอล ที่แรงตันไฟฟ้า 8,000 โวลต์, ความถี่ 500 เฮิร์ซ และ อัตราการใหลของก๊าซขาเข้า 50 ลูกบาศก์เซนติเมตรต่อนาที และที่อัตราส่วนของก๊าซมีเทน, ต่อ ออกซิเจนต่ออีเทนเท่ากับ 4:2:1 ตัวเร่งปฏิกิริยาแพลตินัมบนพื้นผิวโพแทสเซียมซีโอไลต์แอลยัง ช่วยเพิ่มการเปลี่ยนแปลงของก๊าซออกซิเจนและประสิทธิภาพการเกิดจำเพาะของเอทิลีนให้สูงขึ้น ในขณะที่ปฏิกิริยาแบบไม่ใช้ตัวเร่งปฏิกิริยา ผลิตภัณฑ์หลักคือไฮโครเจนและคาร์บอนมอนอกไซค์

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TABLE OF CONTENTS

		PAGE
	Title Page	i
	Abstract (in English)	iii
	Abstract (in Thai)	iv
	Acknowledgements	v
	Table of Contents	vi
	List of Tables	X
	List of Figures	xiv
CHAPTER		
I	INTRODUCTION	1
II	LITERATURE SURVEY	3
	2.1 Physical and Chemical Properties of Methane	3
	2.2 Gaseous Plasmas for Activating Methane Molecules	5
	2.2.1 Fundamental Properties of Plasmas	5
	2.2.2 Generation of Plasmas	6
	2.3 Types of Non-Equilibrium Plasmas	10
	2.3.1 Radio Frequency Discharge	11
	2.3.2 Microwave Discharge	11
	2.3.3 Glow Discharge	11
	2.3.4 Corona Discharge	12
	2.3.5 Dielectric Barrier Discharge	12
	2.4 Related Research Work	13

CHAPTER	P	PAGE
III	EXPERIMENTAL SECTION	19
	3.1 Materials	19
	3.1.1 Catalyst Preparation Materials	19
	3.1.2 Gaseous Reactant Materials	19
	3.2 Catalyst Preparation	20
	3.3 Experimental Setup	21
	3.3.1 Reactant Gases Mixing Section	21
	3.3.2 Reaction Section	21
	3.3.2.1 Power Supply Unit	21
	3.3.2.2 Reactor Unit	24
	3.3.3 Analysis Section	25
	3.4 Experimental Procedure	26
	3.4.1 The Plasma System	26
	3.4.1.1 Study of Ethane Partial Pressure Effect	26
	3.4.1.2 Study of Flow Rate Effect	27
	3.4.1.3 Study of Frequency Effect	27
	3.4.1.4 Study of Voltage Effect	27
	3.4.2 The Catalytic Plasma System	28
	3.4.2.1 Catalyst Reduction Procedure	28
	3.4.2.2 Study of Frequency Effect	28
	3.4.2.3 Study of Voltage Effect	28
	3.4.2.4 Study of Catalyst Types	29
IV	RESULTS AND DISCUSSION	30
	4.1 The Plasma System with the Absence of Catalyst	30

CHAPTER			PAGE
	4.1.1	Effect of Ethane Partial Pressure on	
		Conversions and Yield	31
	4.1.2	Effect of Ethane Partial Pressure on Products	
		Selectivities	32
	4.1.3	Effect of Flow Rate on Conversions	
		and Yield	34
	4.1.4	Effect of Flow Rate on Products	
		Selectivities	36
	4.1.5	Effect of Frequency on Conversions	
		and Yield	37
	4.1.6	Effect of Frequency on Products	
		Selectivities	39
	4.1.7	Effect of Applied Voltage on Conversions	
		and Yield	40
	4.1.8	Effect of Applied Voltage on Products	
		Selectivities	43
4.2	The P	lasma System with the Presence of Catalyst	44
	4.2.1	Effect of Frequency on Conversions	
		and Yield over Pt/KL	44
	4.2.2	Effect of Frequency on Products	
		Selectivities over Pt/KL	45
	4.2.3	Effect of Applied Voltage on Conversions	
		and Yield over Pt/KL	46
	4.2.4	Effect of Applied Voltage on Products	
		Selectivities over Pt/KL	48

CHAPTER		PAGE
	4.2.5 Plasma Catalytic Oxidative Conversion of Methane over Different Zeolites	49
V	CONCLUSIONS AND RECOMMENDATIONS	51
	5.1 Conclusions	51
	5.2 Recommendations	52
	REFERENCES	53
	APPENDICES	55
	CURRICULUM VITAE	66

LIST OF TABLES

TABLE		PAGE
2.1	Average chemical bond energy of some covalent bonds	4
2.2	The first ionization potential of some common gases	4
2.3	Collision mechanisms in the gases	9
4.1	Comparison of non-catalytic and catalytic over the	
	Different zeolites system on conversions and yield at	
	$CH_4:O_2:C_2H_6$ ratio = 4:2:1. Applied voltage: 6000 V.	
	Flow rate: 50 ml/min. Gap width: 1.3 cm. Frequency:	
	500 Hz.	50
4.2	Comparison of non-catalytic and catalytic over the	
	different zeolites system on products selectivities at	
	$CH_4: O_2: C_2H_6$ ratio = 4:2:1. Applied voltage: 6000 V.	
	Flow rate: 50 ml/min. Gap width: 1.3 cm. Frequency:	
	500 Hz.	50
B.1	Ethane partial pressure on partial pressure of effluent	
	gases at total flow rate 100 ml/min, gap width 1.3 cm,	
	applied voltage 8,000 V and frequency 400 Hz	57
B.2	Ethane partial pressure on conversions and yield at	
	total flow rate 100 ml/min, gap width 1.3 cm, applied	
	voltage 8,000 V and frequency 400 Hz	57
B.3	Ethane partial pressure on product selectivities at	
	total flow rate 100 ml/min, gap width 1.3 cm, applied	
	voltage 8,000 V and frequency 400 Hz	58

TABLE		PAGE
B 4	Flow rate on partial pressure of effluent gases at	
Б	methane, oxygen and ethane ratio 4:2:1, gap width	
	1.3 cm, applied voltage 8,000 V and frequency 400 Hz	58
B.5	Flow rate on conversions and yield at methane,	
	oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
	applied voltage 8,000 V and frequency 400 Hz	59
B.6	Flow rate on product selectivities at methane,	
	oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
	applied voltage 8,000 V and frequency 400 Hz	59
B.7	Frequency on partial pressure of effluent gases at	
	methane, oxygen and ethane ratio 4:2:1, gap width	
	1.3 cm, applied voltage 8,000 V and total flow rate	
	50 ml/min	60
B.8	Frequency on conversions and yield at methane,	
	oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
	applied voltage 8,000 V and total flow rate 50 ml/min	60
B.9	Frequency on current at methane, oxygen and ethane	
	ratio 4:2:1, gap width 1.3 cm, applied voltage 8,000 V	
	and total flow rate 50 ml/min	60
B.10	Frequency on product selectivities at methane,	
	oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
	applied voltage 8,000 V and total flow rate 50 ml/min	61
B.11	Voltage on partial pressure of effluent gases at methane,	
	oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
	frequency 500 Hz and total flow rate 50 ml/min	61

TABLE	
B.12 Voltage on conversions and yield at methane, oxygen	
and ethane ratio 4:2:1, gap width 1.3 cm, frequency	
500 Hz and total flow rate 50 ml/min	62
B.13 Voltage on current at methane, oxygen and ethane	
ratio 4:2:1, gap width 1.3 cm, frequency 500 Hz and	
total flow rate 50 ml/min	62
B.14 Voltage on product selectivities at methane, oxygen	
and ethane ratio 4:2:1, gap width 1.3 cm, frequency	
500 Hz and total flow rate 50 ml/min	62
B.15 Frequency on partial pressure of effluent gases at	
methane, oxygen and ethane ratio 4:2:1, gap width	
1.3 cm, applied voltage 8,000 V and total flow rate	
50 ml/min	63
B.16 Frequency on conversions and yield at methane,	
oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
applied voltage 8,000 V and total flow rate 50 ml/min	63
B.17 Frequency on current at methane, oxygen and ethane	
ratio 4:2:1, gap width 1.3 cm, applied voltage 8,000 V	
and total flow rate 50 ml/min	64
B.18 Frequency on product selectivities at methane, oxygen	
and ethane ratio 4:2:1, gap width 1.3 cm, applied	
voltage 8,000 V and total flow rate 50 ml/min	64
B.19 Voltage on partial pressure of effluent gases at methane,	
oxygen and ethane ratio 4:2:1, gap width 1.3 cm,	
frequency 500 Hz and total flow rate 50 ml/min	64

TABLE	PAGE
B.20 Voltage on conversions and yield at methane, oxygen	
and ethane ratio 4:2:1, gap width 1.3 cm, frequency	
500 Hz and total flow rate 50 ml/min	65
B.21 Voltage on current at methane, oxygen and ethane	
ratio 4:2:1, gap width 1.3 cm, frequency 500 Hz and	
total flow rate 50 ml/min	65
B.22 Voltage on product selectivities at methane, oxygen	
and ethane ratio 4:2:1, gap width 1.3 cm, frequency	
500 Hz and total flow rate 50 ml/min	65

LIST OF FIGURES

FIGURE	
2.1 Alternative methods of charged particles generation	7
3.1 Flow diagram of plasma reactor system	22
3.2 Schematic diagram of power supply unit	23
3.3 The corona discharge reactor	24
4.1 Effect of ethane partial pressure on partial pressure	
of effluent gases. Flow rate: 100 ml/min. Applied	
voltage: 8000 V. Frequency: 400 Hz. Gap width: 1.3 cm	31
4.2 Effect of ethane partial pressure on conversions and yield.	
Flow rate: 100 ml/min. Applied voltage: 8000 V.	
Frequency: 400 Hz. Gap width: 1.3 cm.	31
4.3 Effect of ethane partial pressure on products selectivities.	
Flow rate: 100 ml/min. Applied voltage: 8000 V.	
Frequency: 400 Hz. Gap width: 1.3 cm.	32
4.4 Effect of flow rate on partial pressure of effluent gases.	
CH ₄ :O ₂ :C ₂ H ₆ =4:2:1. Applied voltage: 8000 V.	
Frequency: 400 Hz.Gap width: 1.3 cm.	35
4.5 Effect of flow rate on conversions and yield.	
CH ₄ :O ₂ :C ₂ H ₆ =4:2:1. Applied voltage: 8000 V.	
Frequency: 400 Hz. Gap width: 1.3 cm.	35
4.6 Effect of flow rate on products selectivities.	
CH ₄ :O ₂ :C ₂ H ₆ =4:2:1. Applied voltage: 8000 V.	
Frequency: 400 Hz. Gan width: 1.3 cm	36

FIGURE	
4.7 Effect of frequency on partial pressure of effluent gases.	
$CH_4:O_2:C_2H_6=4:2:1$. Applied voltage: 8000 V. Flow	
rate: 50 ml/min. Gap width: 1.3 cm.	37
4.8 Effect of frequency on conversions and yield.	
$CH_4: O_2: C_2H_6 = 4:2:1$. Applied voltage: 8000 V. Flow	
rate: 50 ml/min. Gap width: 1.3 cm.	38
4.9 Effect of frequency on current. CH ₄ :O ₂ :C ₂ H ₆ =	
4:2:1. Applied voltage: 8000 V. Flow rate: 50 ml/min.	
Gap width: 1.3 cm.	38
4.10 Effect of frequency on products selectivities.	
$CH_4:O_2:C_2H_6=4:2:1$. Applied voltage: 8000 V. Flow	
rate: 50 ml/min. Gap width: 1.3 cm.	40
4.11 Effect of voltage on partial pressure of effluent gases.	
$CH_4:O_2:C_2H_6=4:2:1$. Frequency: 500 Hz. Flow rate:	
50 ml/min. Gap width: 1.3 cm.	41
4.12 Effect of voltage on conversions and yield.	
$CH_4:O_2:C_2H_6=4:2:1$. Frequency: 500 Hz. Flow rate:	
50 ml/min. Gap width: 1.3 cm.	42
4.13 Effect of voltage on current. $CH_4:O_2:C_2H_6=4:2:1$.	
Frequency: 500 Hz. Flow rate: 50 ml/min. Gap width: 1.3 cm.	42
4.14 Effect of voltage on products selectivities.	
$CH_4:O_2:C_2H_6=4:2:1$. Frequency: 500 Hz. Flow rate:	
50 ml/min. Gap width: 1.3 cm.	43

FIGURE	PAGE	
4.15 Effect of frequency on partial pressure of effluent		
gases over Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1.		
Applied voltage: 8000 V. Flow rate: 50 ml/min.		
Gap width: 1.3 cm.	44	
4.16 Effect of frequency on conversions and yield		
over Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1.		
Applied voltage: 8000 V. Flow rate: 50 ml/min.	45	
4.17 Effect of frequency on products selectivities		
over Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1.		
Applied voltage: 8000 V. Flow rate: 50 ml/min.	46	
4.18 Effect of voltage on conversions and yield		
over Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1.		
Frequency: 500 Hz. Flow rate: 50 ml/min.	47	
4.19 Effect of voltage on conversions and yield		
over Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1.		
Frequency: 500 Hz. Flow rate: 50 ml/min.	47	
4.20 Effect of voltage on products selectivities over		
Pt/KL system. $CH_4:O_2:C_2H_6$ ratio = 4:2:1. Frequency:		
500 Hz Flow rate: 50 ml/min	49	